

## Refine Search

### Search Results -

Terms	Documents
L3 and radii and axes	2

Database:

US Pre-Grant Publication Full-Text Database  
 US Patents Full-Text Database  
 US OCR Full-Text Database  
 EPO Abstracts Database  
 JPO Abstracts Database  
 Derwent World Patents Index  
 IBM Technical Disclosure Bulletins

Search:

L4

Refine Search

Recall Text

Clear

Interrupt

### Search History

 DATE: Thursday, September 30, 2004    [Printable Copy](#)    [Create Case](#)
**Set Name Query**

side by side

**Hit Count Set Name**

result set

*DB=USPT; PLUR=YES; OP=ADJ*

<u>L4</u>	L3 and radii and axes	2	<u>L4</u>
<u>L3</u>	L2 and (ignots or legs)	7	<u>L3</u>
<u>L2</u>	L1 and (support adj fixture)	8	<u>L2</u>
<u>L1</u>	monocrystalline and (virgin adj polysilicon)	10	<u>L1</u>

END OF SEARCH HISTORY

## Hit List

Clear	Generate Collection	Print	Fwd Refs	Bkwd Refs
Generate OACS				

Search Results - Record(s) 1 through 2 of 2 returned.

☐ 1. Document ID: US 6455395 B1

L4: Entry 1 of 2

File: USPT

Sep 24, 2002

US-PAT-NO: 6455395

DOCUMENT-IDENTIFIER: US 6455395 B1

TITLE: Method of fabricating silicon structures including fixtures for supporting wafers

Full	Title	Citation	Front	Review	Classification	Date	Reference			Claims	RWC	Draw. Doc
------	-------	----------	-------	--------	----------------	------	-----------	--	--	--------	-----	-----------

☐ 2. Document ID: US 6450346 B1

L4: Entry 2 of 2

File: USPT

Sep 17, 2002

US-PAT-NO: 6450346

DOCUMENT-IDENTIFIER: US 6450346 B1

TITLE: Silicon fixtures for supporting wafers during thermal processing

Full	Title	Citation	Front	Review	Classification	Date	Reference			Claims	RWC	Draw. Doc
------	-------	----------	-------	--------	----------------	------	-----------	--	--	--------	-----	-----------

Clear	Generate Collection	Print	Fwd Refs	Bkwd Refs	Generate OACS
-------	---------------------	-------	----------	-----------	---------------

Terms	Documents
L3 and radii and axes	2

Display Format:

[Previous Page](#)

[Next Page](#)

[Go to Doc#](#)

## Hit List

[Clear](#) [Generate Collection](#) [Print](#) [Fwd Refs](#) [Bkwd Refs](#)  
[Generate OACS](#)

### Search Results - Record(s) 1 through 7 of 7 returned.

☐ 1. Document ID: US 6727191 B2

L3: Entry 1 of 7

File: USPT

Apr 27, 2004

US-PAT-NO: 6727191

DOCUMENT-IDENTIFIER: US 6727191 B2

TITLE: High temperature hydrogen anneal of silicon wafers supported on a silicon fixture

Full	Title	Citation	Front	Review	Classification	Date	Reference	Claims	KWC	Draw D
------	-------	----------	-------	--------	----------------	------	-----------	--------	-----	--------

☐ 2. Document ID: US 6617225 B2

L3: Entry 2 of 7

File: USPT

Sep 9, 2003

US-PAT-NO: 6617225

DOCUMENT-IDENTIFIER: US 6617225 B2

TITLE: Method of machining silicon

Full	Title	Citation	Front	Review	Classification	Date	Reference	Claims	KWC	Draw D
------	-------	----------	-------	--------	----------------	------	-----------	--------	-----	--------

☐ 3. Document ID: US 6583377 B2

L3: Entry 3 of 7

File: USPT

Jun 24, 2003

US-PAT-NO: 6583377

DOCUMENT-IDENTIFIER: US 6583377 B2

TITLE: Welded silicon member

Full	Title	Citation	Front	Review	Classification	Date	Reference	Claims	KWC	Draw D
------	-------	----------	-------	--------	----------------	------	-----------	--------	-----	--------

☐ 4. Document ID: US 6455395 B1

L3: Entry 4 of 7

File: USPT

Sep 24, 2002

US-PAT-NO: 6455395

DOCUMENT-IDENTIFIER: US 6455395 B1

TITLE: Method of fabricating silicon structures including fixtures for supporting wafers

Full	Title	Citation	Front	Review	Classification	Date	Reference			Claims	KWIC	Draw D
------	-------	----------	-------	--------	----------------	------	-----------	--	--	--------	------	--------

☐ 5. Document ID: US 6450346 B1

L3: Entry 5 of 7

File: USPT

Sep 17, 2002

US-PAT-NO: 6450346

DOCUMENT-IDENTIFIER: US 6450346 B1

TITLE: Silicon fixtures for supporting wafers during thermal processing

Full	Title	Citation	Front	Review	Classification	Date	Reference			Claims	KWIC	Draw D
------	-------	----------	-------	--------	----------------	------	-----------	--	--	--------	------	--------

☐ 6. Document ID: US 6403914 B1

L3: Entry 6 of 7

File: USPT

Jun 11, 2002

US-PAT-NO: 6403914

DOCUMENT-IDENTIFIER: US 6403914 B1

TITLE: Method for welding silicon workpieces

Full	Title	Citation	Front	Review	Classification	Date	Reference			Claims	KWIC	Draw D
------	-------	----------	-------	--------	----------------	------	-----------	--	--	--------	------	--------

☐ 7. Document ID: US 6284997 B1

L3: Entry 7 of 7

File: USPT

Sep 4, 2001

US-PAT-NO: 6284997

DOCUMENT-IDENTIFIER: US 6284997 B1

TITLE: Crack free welding of silicon

Full	Title	Citation	Front	Review	Classification	Date	Reference			Claims	KWIC	Draw D
------	-------	----------	-------	--------	----------------	------	-----------	--	--	--------	------	--------

Clear	Generate Collection	Print	Fwd Refs	Bkwd Refs	Generate OACS
-------	---------------------	-------	----------	-----------	---------------

Terms	Documents
L2 and (ignots or legs)	7

Display Format: TI Change Format

[Previous Page](#)

[Next Page](#)

[Go to Doc#](#)